

Form PTO-1449

U.S. DEPARTMENT OF COMMERCE  
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M122-1330SERIAL NO.  
09/653,149LIST OF ART CITED BY APPLICANT  
(Use several sheets if necessary)

APPLICANT Garo J. Derderian

FILING DATE  
August 31, 2000GROUP  
2812

## U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
<i>RL</i>	AA	09/652,532		Derderian			08/31/00
<i>RL</i>	AB	09/653,156		Agarwal			08/31/00
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						

## FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AM							
	AN							
	AO							

## OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

	AP		A.W. Ott, et al., "Atomic layer controlled deposition of Al <sub>2</sub> O <sub>3</sub> films using binary reaction sequence chemistry" Applied Surface Science (107) 1996, pps. 128-136.
	AQ		
	AR		

EXAMINER

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.